

# ELECTRON ACCELERATOR FOR RADIATION STERILIZATION AND R&D STUDY

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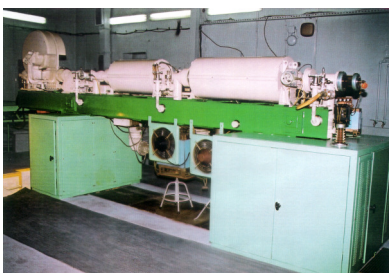
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# **ELECTRON ACCELERATORS IN**

## **Centre for Radiation Research and Technology of Institute of Nuclear Chemistry and Technology**

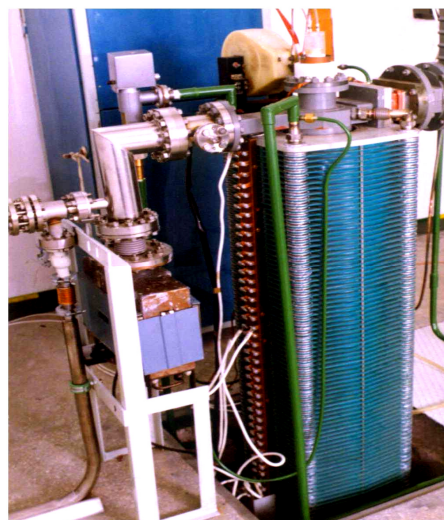
### ***LAE 13/9***

Linear, energy 10–13 MeV,  
beam power up to 9 kW  
Manufacturer: NIIEFA,  
St. Petersburg, Russia  
R&D, Installation: 1971



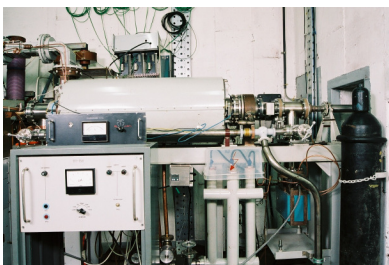
### ***2 x Elektronika 10/10***

Linear, energy 10 MeV,  
beam power up to 10 kW  
Manufacturer: TORIJ,  
Moscow, Russia  
Radiation sterilization and  
Food products treatment,  
Installation: 1993



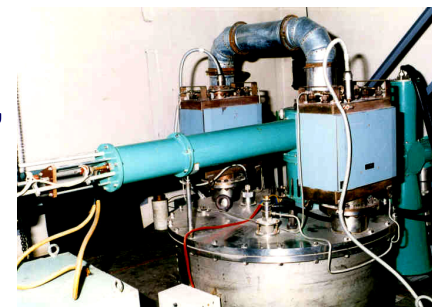
### ***LAE 10***

Linear, 10 nanosecond single  
pulse mode, energy 10 MeV,  
Manufacturer: INCT, Poland  
Pulse Radiolysis Research  
Installation: 2001



### ***IKU – 6***

Resonance Cavity,  
energy range 0.5–2 MeV,  
beam power up to 20 kW,  
Manufacturer: INP  
Novosibirsk, Russia  
Polymer cross-linking,  
flue gas treatment  
Installation: 1988

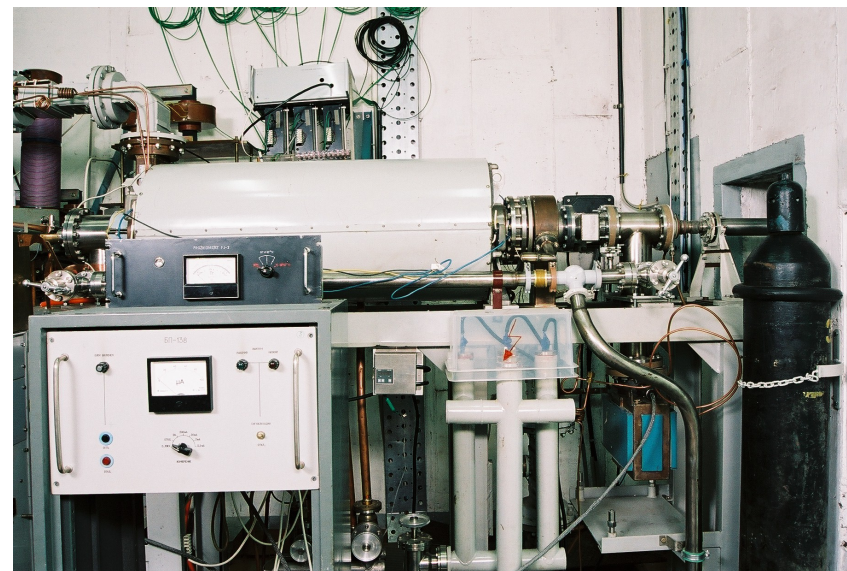
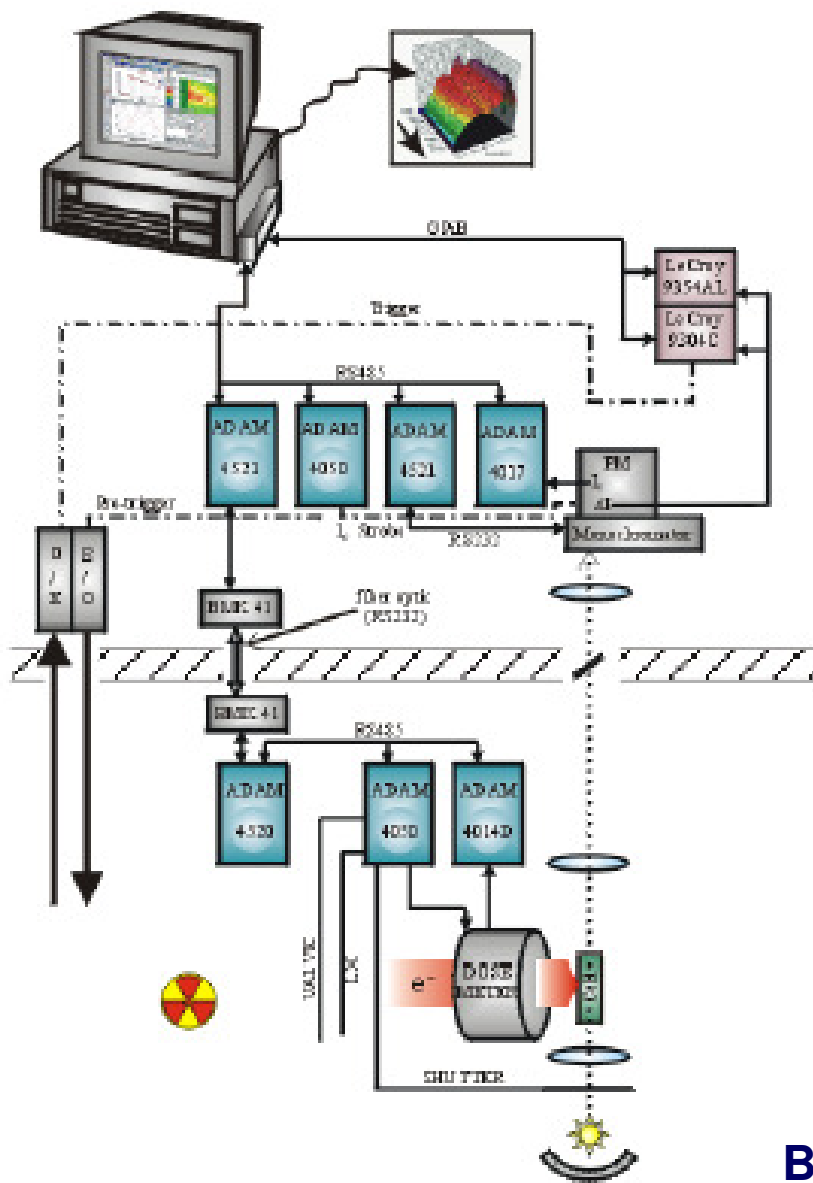


### ***AS – 2000***

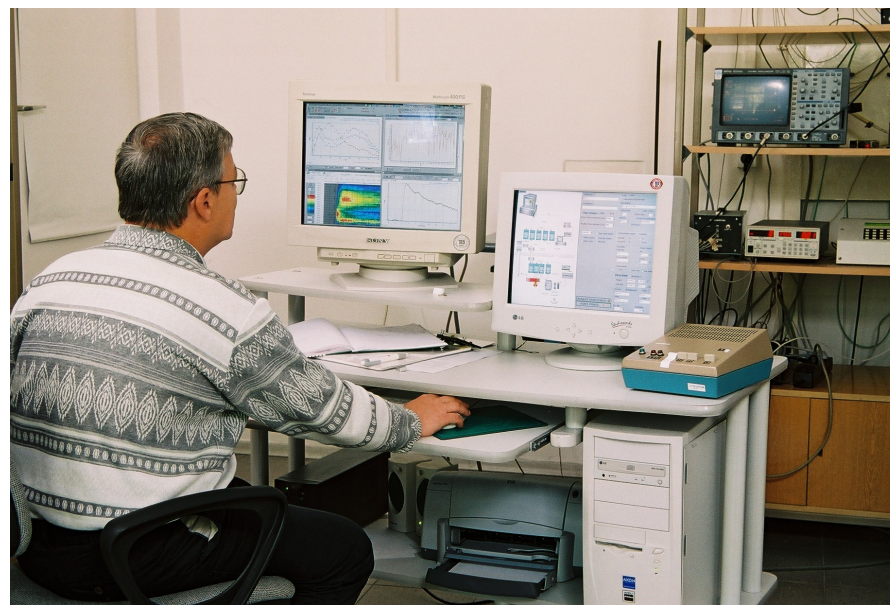
Van de Graaff type,  
electron beam 0-100  $\mu$ A,  
energy range 1-1.5 MeV,  
Manufacturer:  
HV Engineering,  
Netherlands.  
Research on radiation  
modification of  
semiconductors  
Installation at INCT: 1987



# ACCELERATOR LAE 10



**Energy 10 MeV, Pulse duration 10 ns**



**Basic research: pulse radiolysis experiments**

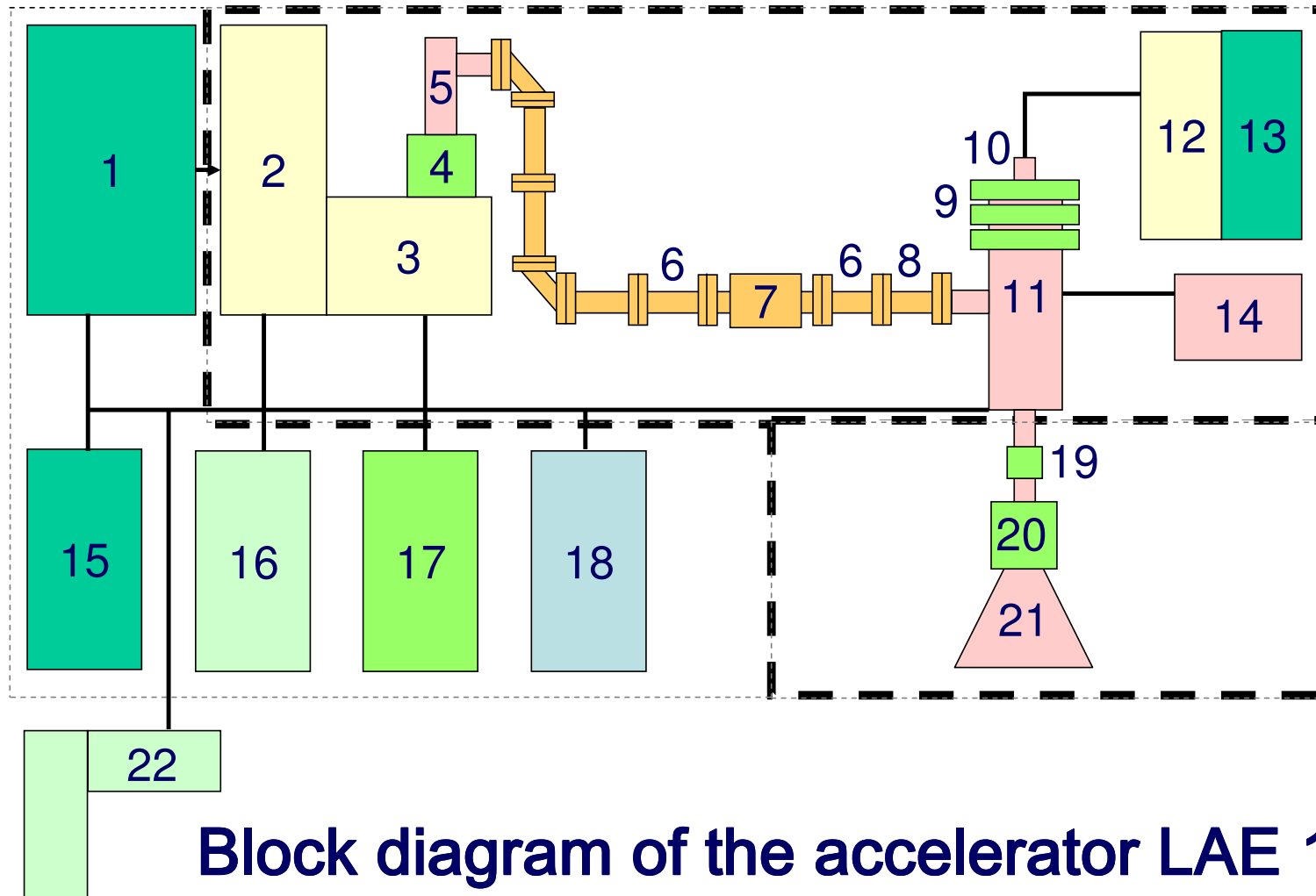
Upgrading of radiation facility located at Centre for Radiation Research and Technology of INCT in Warsaw has been initiated towards:

- higher technical and economical effectiveness,
- better operational characteristics (better accelerator availability, more stable beam parameters, better spare parts availability),
- radiation sterilization of medical devices and tissue grafts,
- radiation processing and research program.

The objective of the project is 10 MeV of electron energy and 15 kW beam power linear electron accelerator equipped with standing wave accelerating section and microwave source based on modern klystron type TH2158 operated at frequency 2856 MHz.

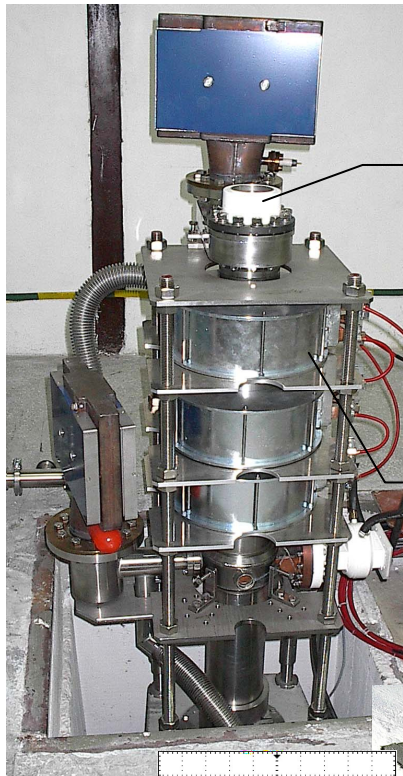
The following stages of the project have been completed:

- electron gun construction and testing,
- electron gun modulator stand,
- microwave system of accelerator (driving generator, pulse amplifier, high power klystron TH 2158 and waveguide components),
- pulse power modulator stand based on semiconductor HV high current transistor switch,
- control system based on microprocessor system (Siemens modules S7-300),
- vacuum system,
- water cooling system.



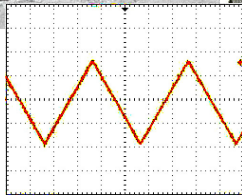
## Block diagram of the accelerator LAE 10/15

1 – HV power supply 13 kV, 50 kW; 2 – modulator; 3 – pulse transformer 135 kV; 4 – focusing coils; 5 – klystron; 6 – directional coupler; 7 – circulator; 8 – RF window; 9 – focusing coil; 10 – electron gun; 11 – accelerating section; 12 – gun modulator; 5 kV; 13 – gun modulator 50 kV; 14 – vacuum pumps; 15 – AC panel; 16 – PLC microprocessor; 17 – auxiliary equipment; 18 – water cooling system; 19 – beam current monitor; 20 – scanning electromagnet; 21 – scanner; 22 – control desk

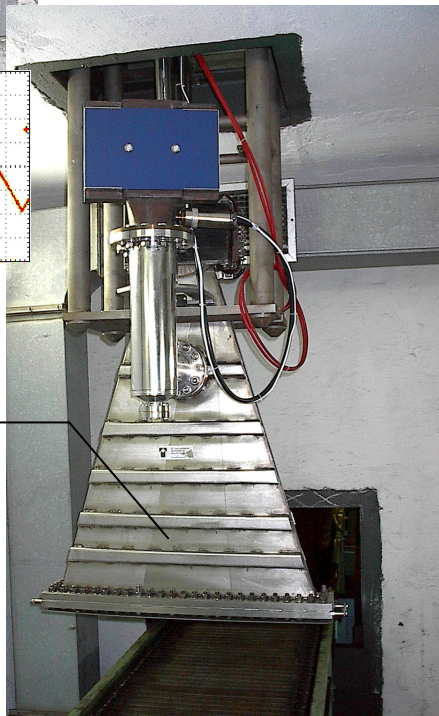


Gun

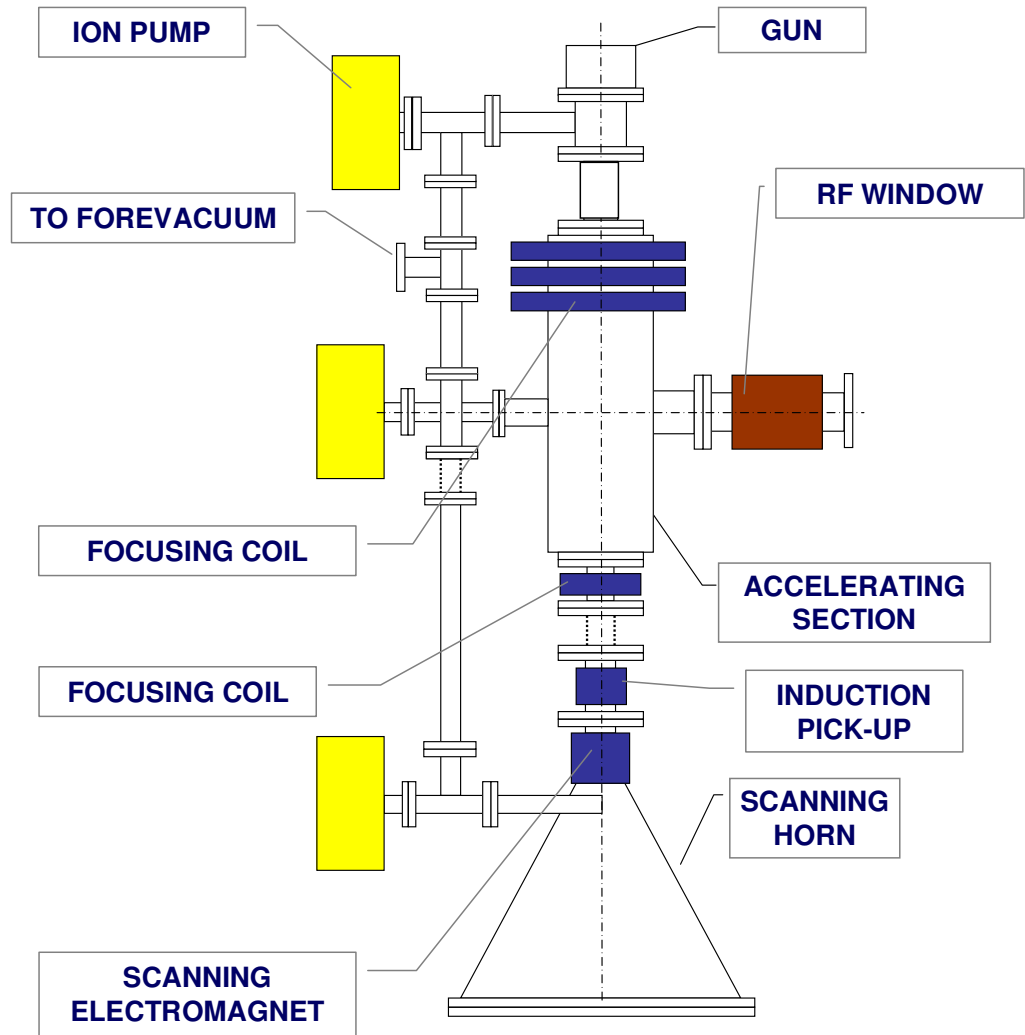
Focusing coils

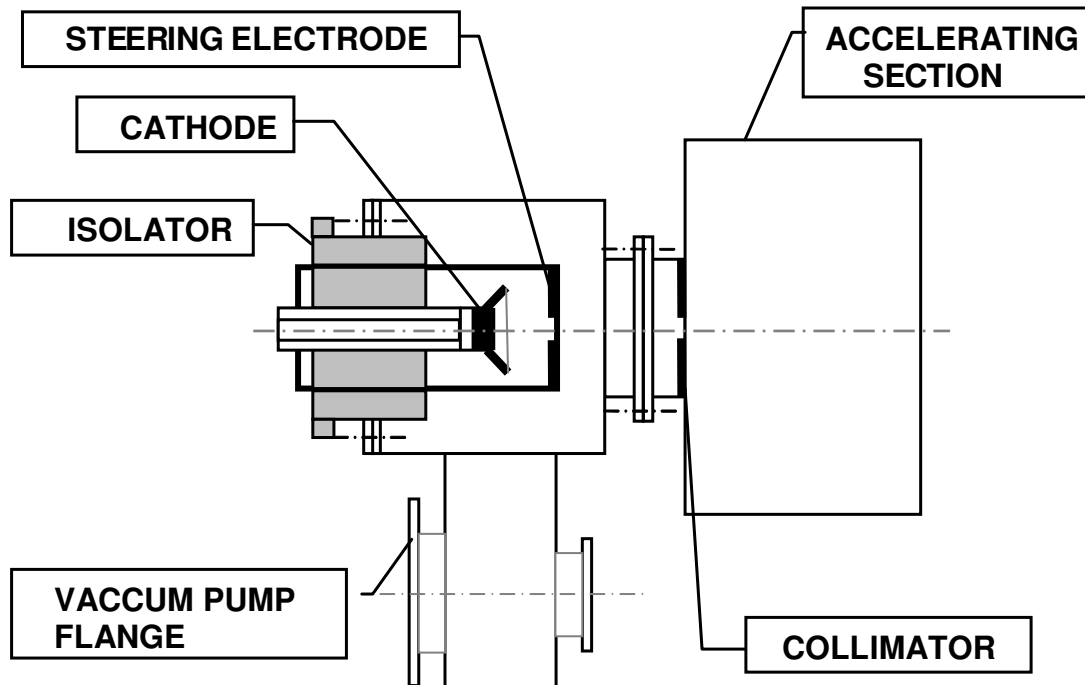
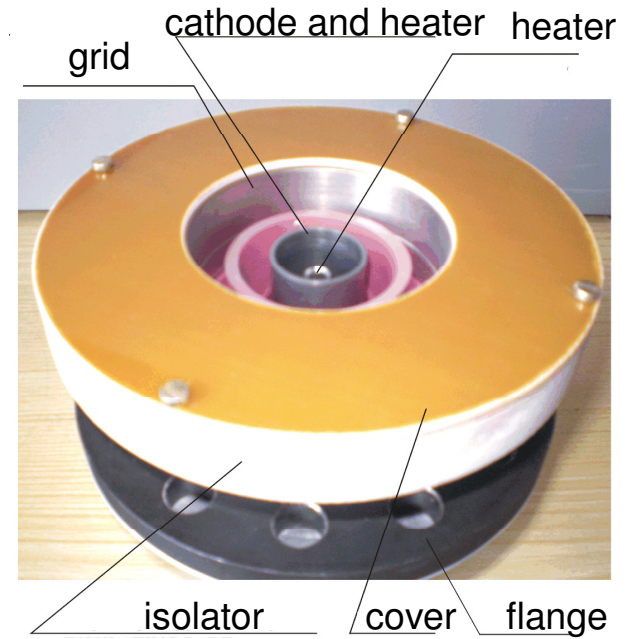
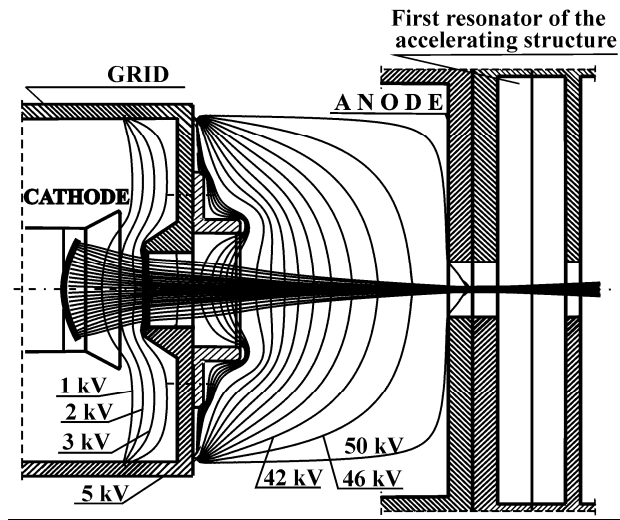


Scanner



## Linear electron accelerator 10 MeV; 15 kW

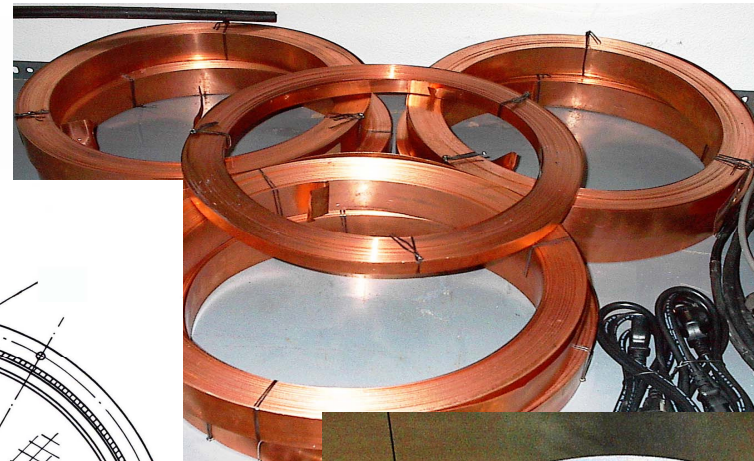
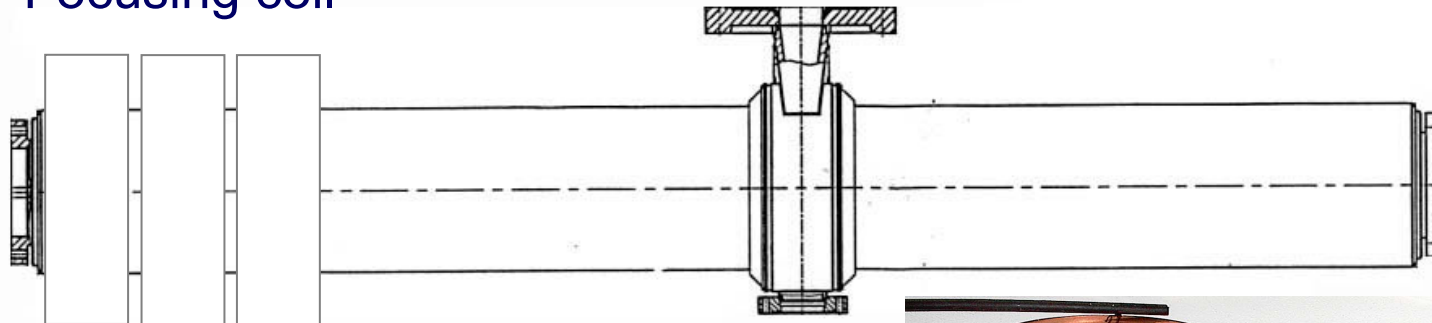




**Electron gun alignment**

# Accelerating section

Focusing coil

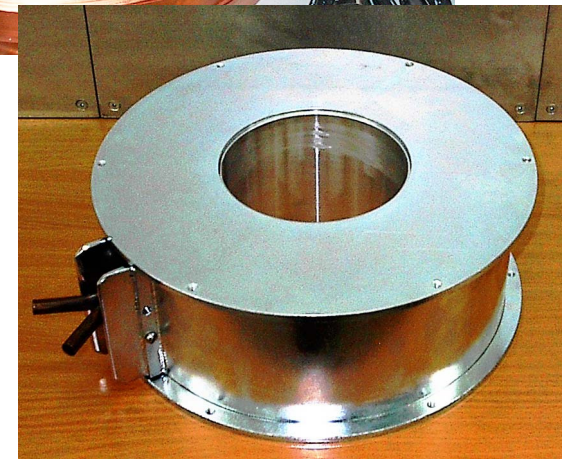
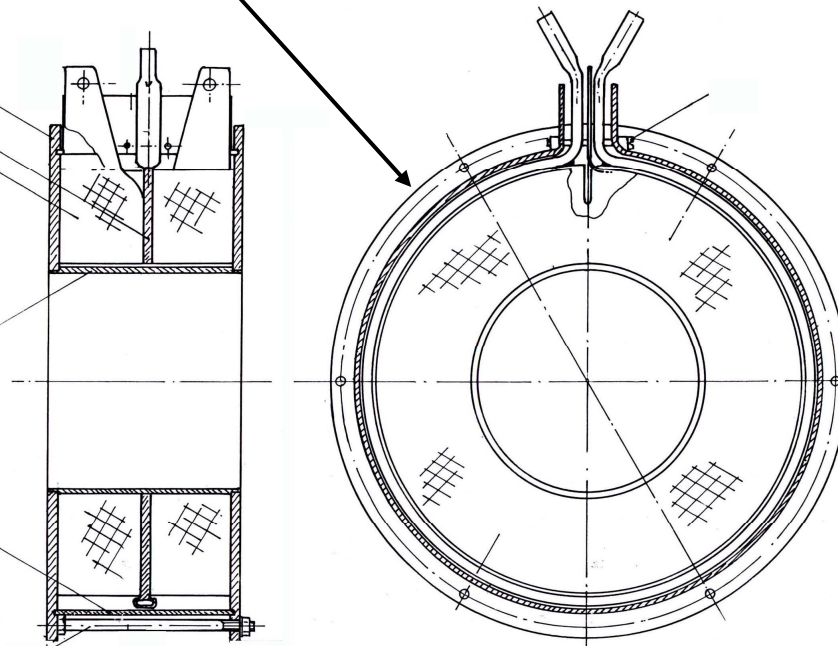


Cover  
Cooling plate  
Winding

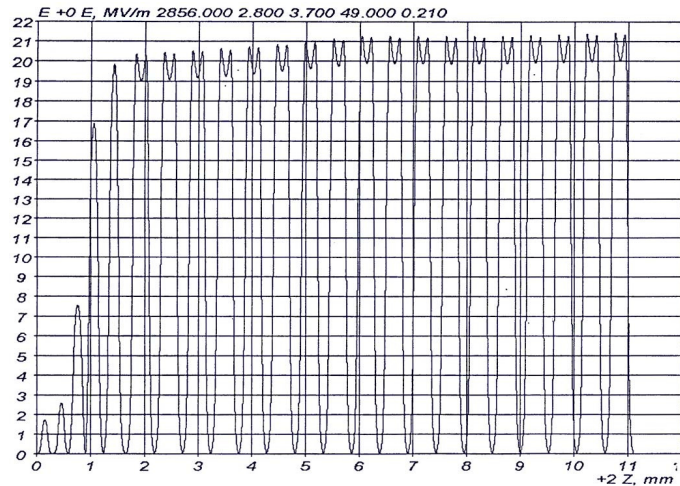
Cylinder

Armature

Bolt

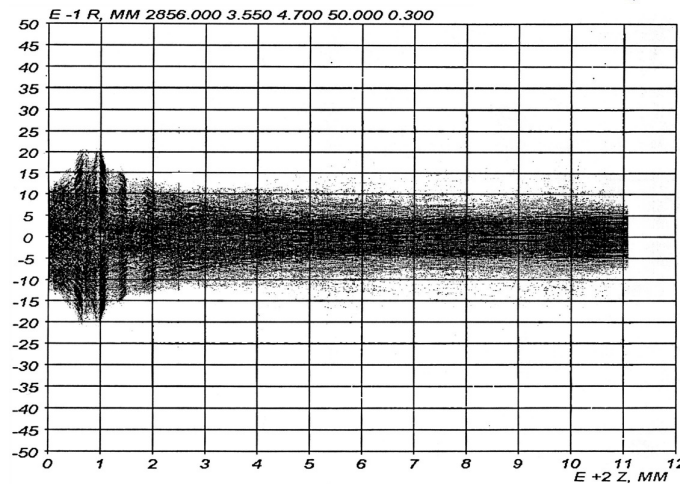


# Performances of accelerating section



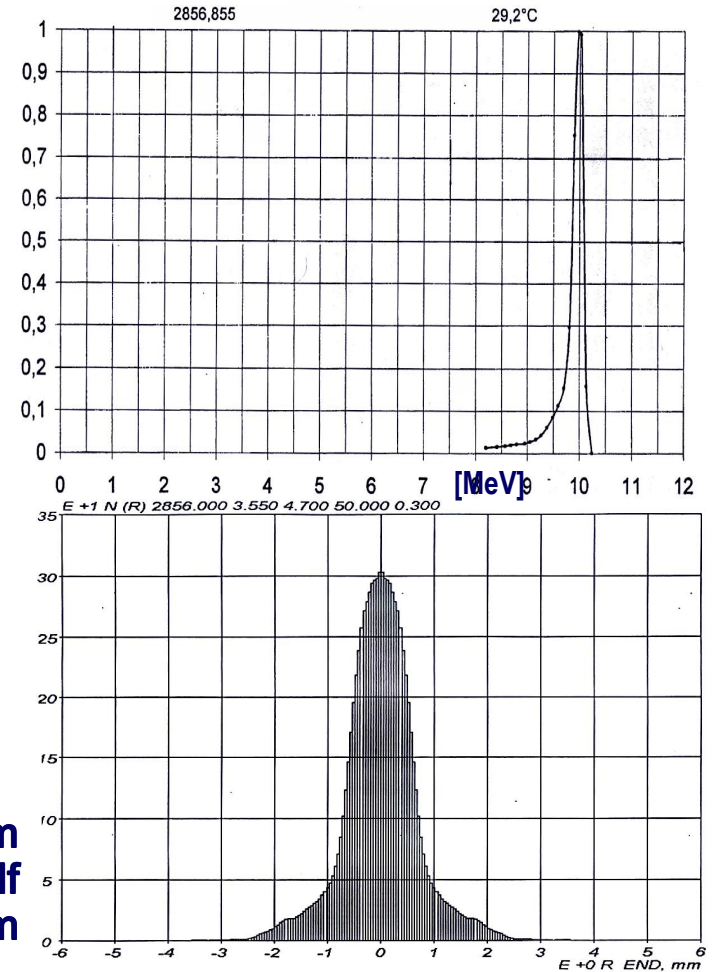
**Electrical field  
distribution along  
accelerating section**

**Electron energy  
spectrum:  $\pm 1,5 \%$**



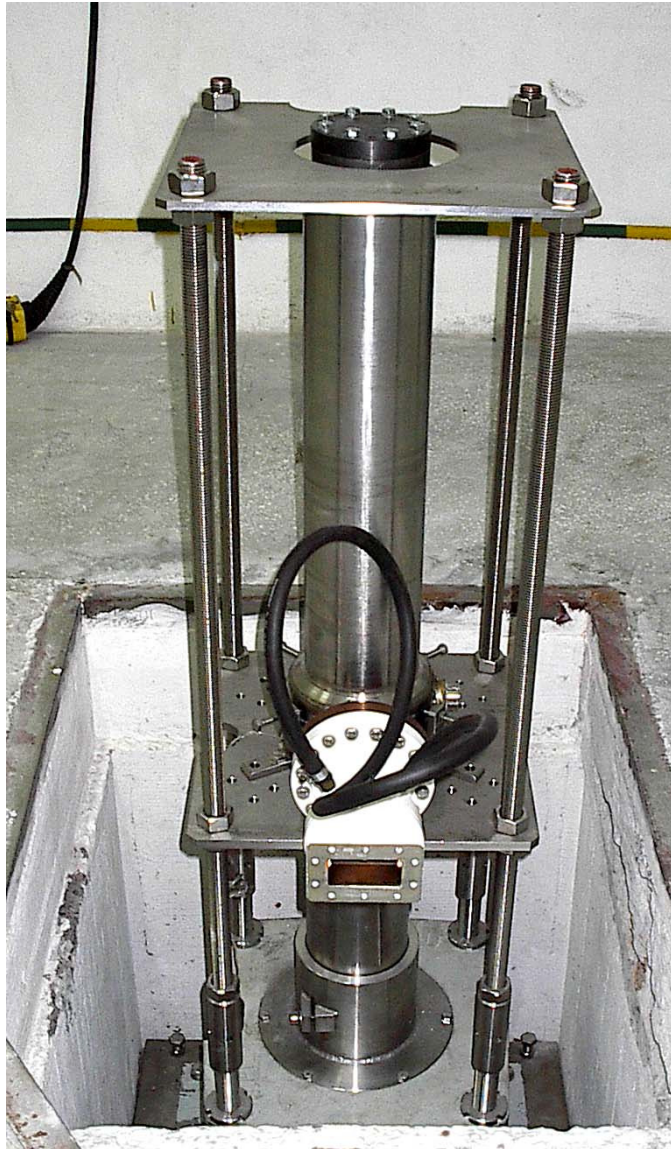
**Electron beam  
diameter along  
accelerating section**

**Beam diameter: 5 mm  
Beam diameter in a half  
height: 1,2 mm**



Accelerating section was designed and built by NIIEFA, St Petersburg, Russia and provided under TC project supported by IAEA

# Accelerating section in assembling holder

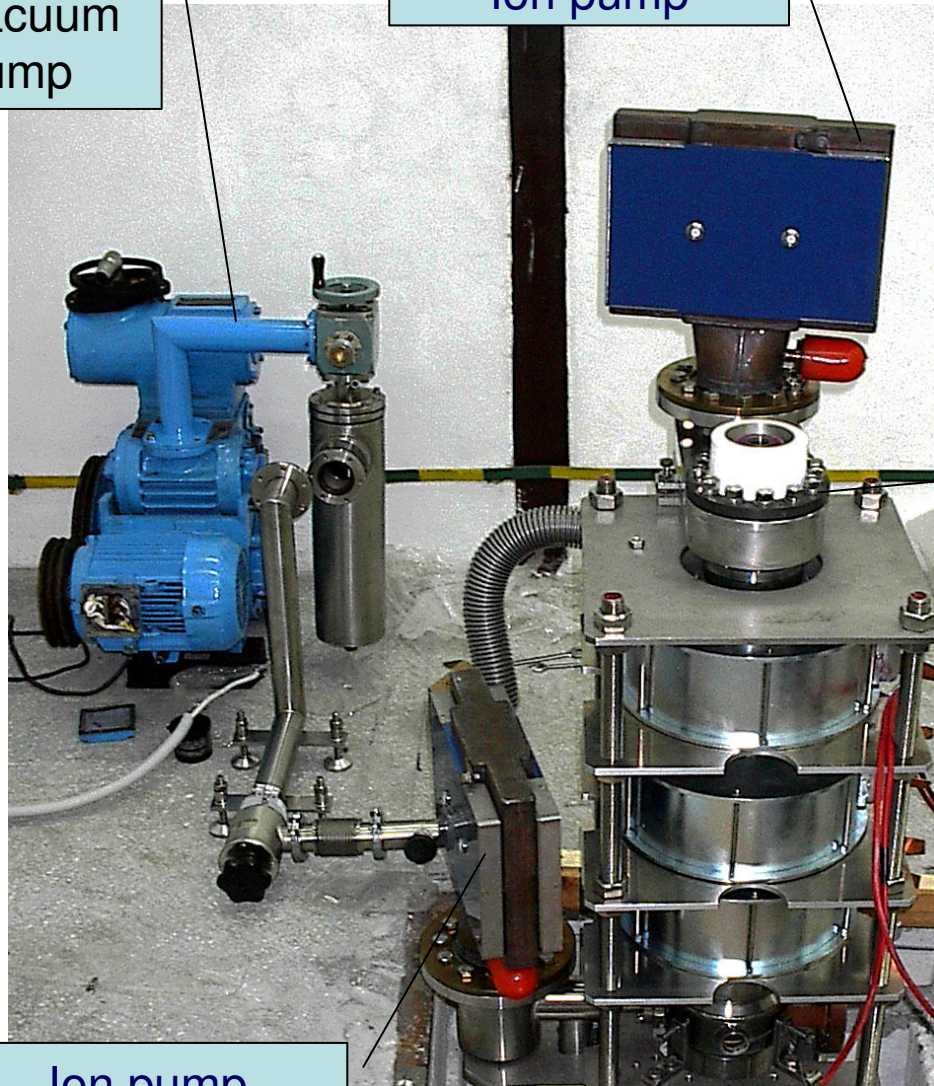


Parameter	Value
Electron energy	10 MeV
Beam power	15 kW
Frequency	2856 MHz
Type of sw oscillation	$\pi/2$
RF pulse power	3.7 MW
RF average power	28 kW
Section efficiency	up to 58 %
Q factor	14800
Impedance	2.9 M $\Omega$
RF pulse duration	25 $\mu$ s
Repetition rate	300 Hz
Beam pulse duration	23 $\mu$ s
Injection electron energy	50 kV
Beam pulse current	210 mA
Electron gun pulse current	300 mA
Electron capture coefficient	up to 85 %

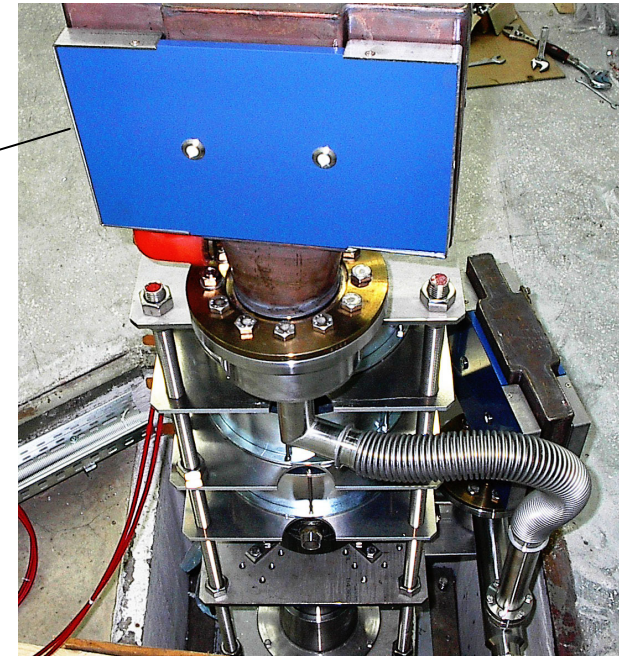
# VACUUM SYSTEM

Fore-  
vacuum  
pump

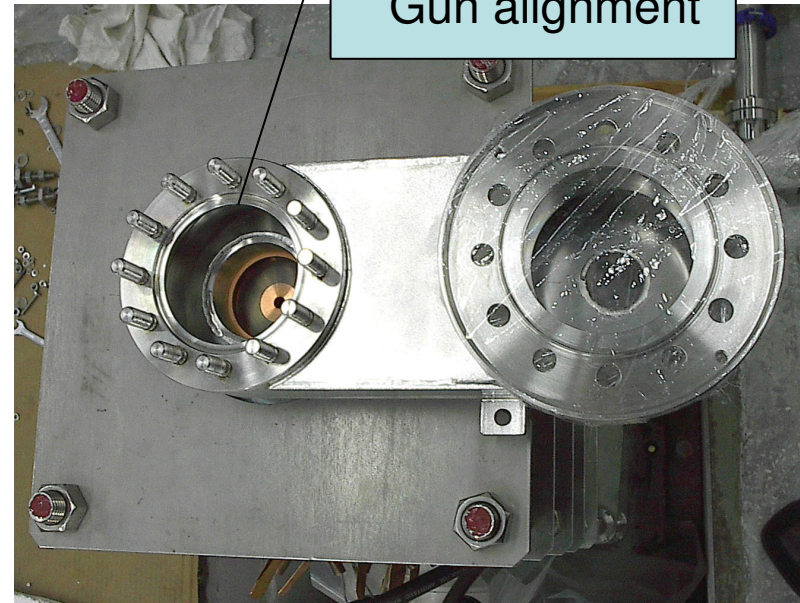
Ion pump



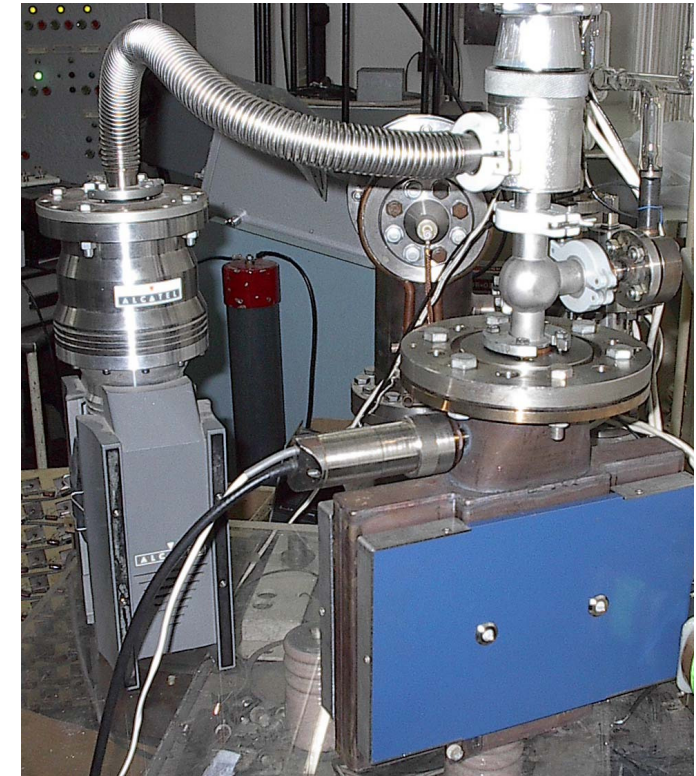
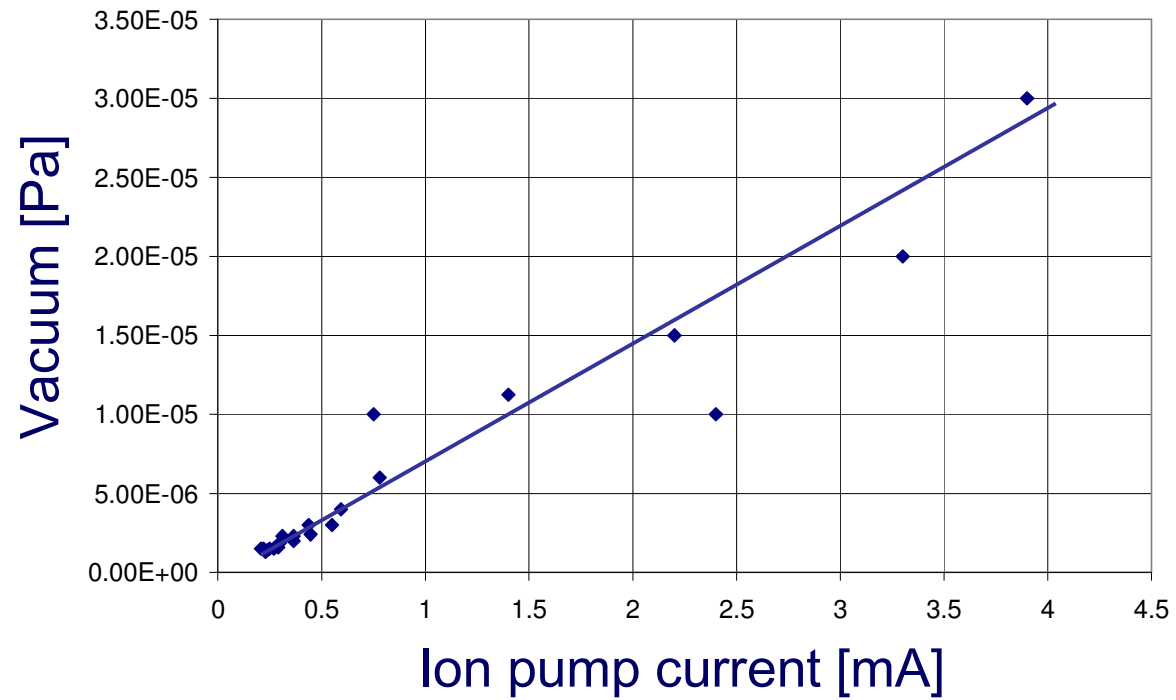
Ion pump



Gun alignment



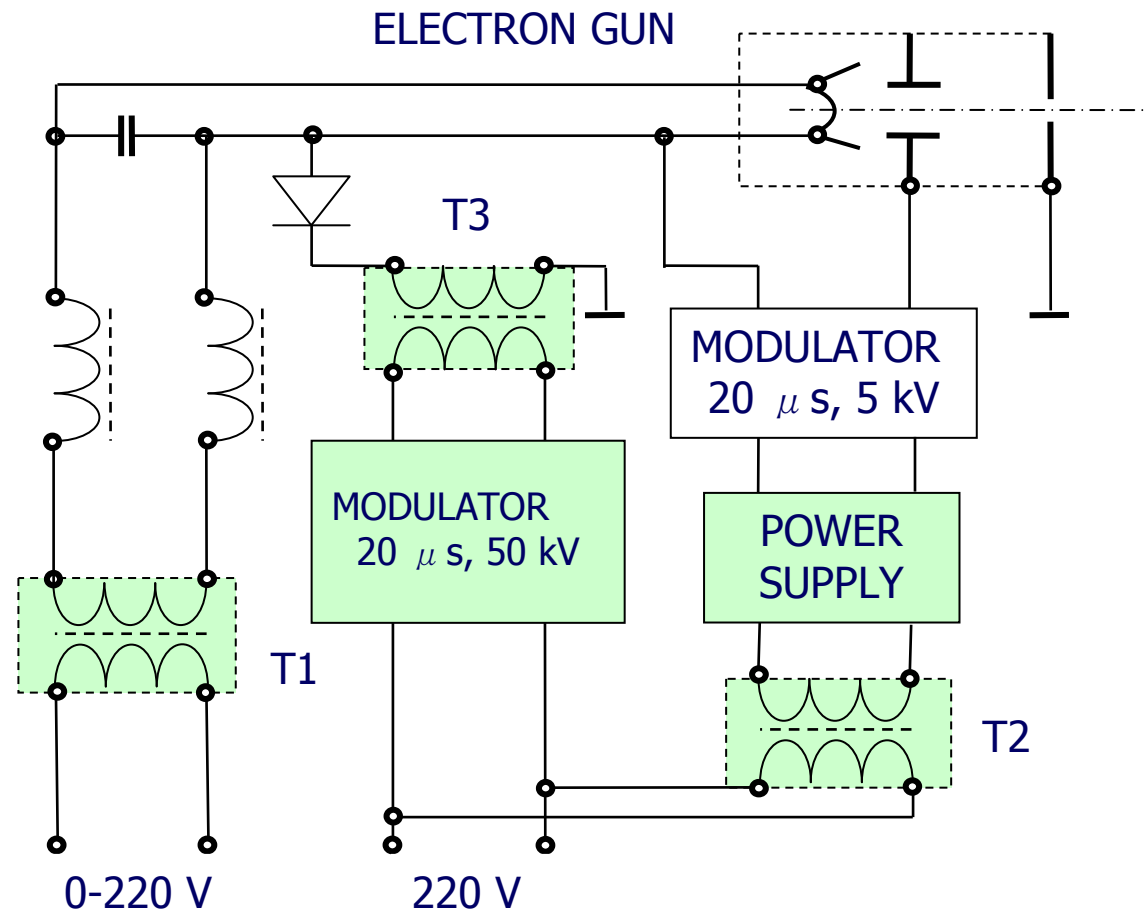
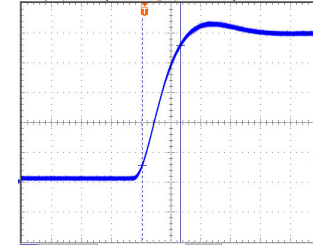
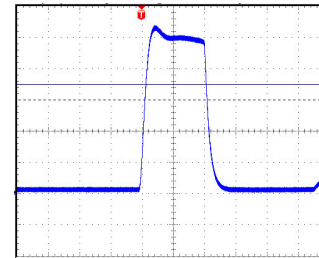
# Vacuum system: calibration curve



# Electron gun supply system

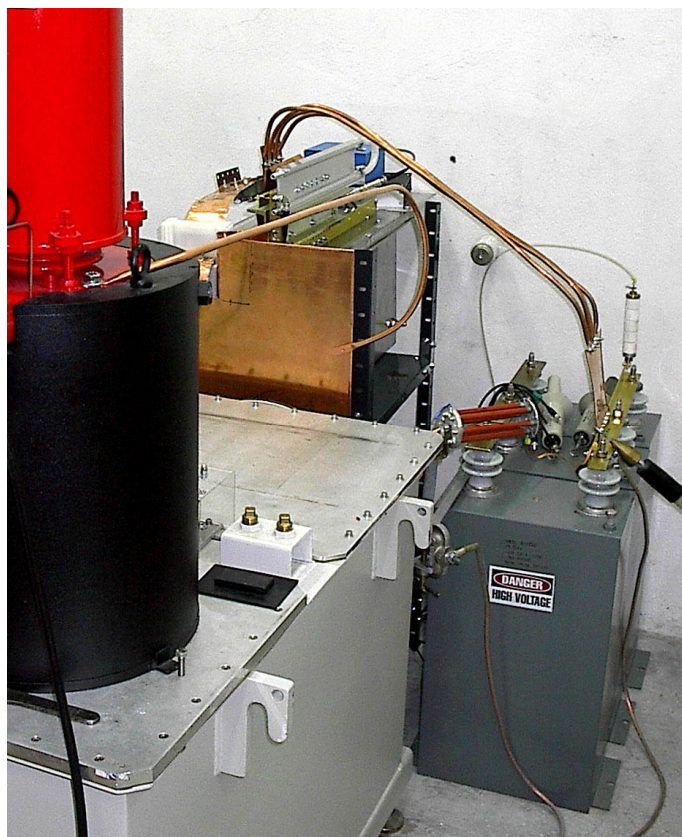


Modulator 20  $\mu$ s, 50 kV  
North Star Power Engineering

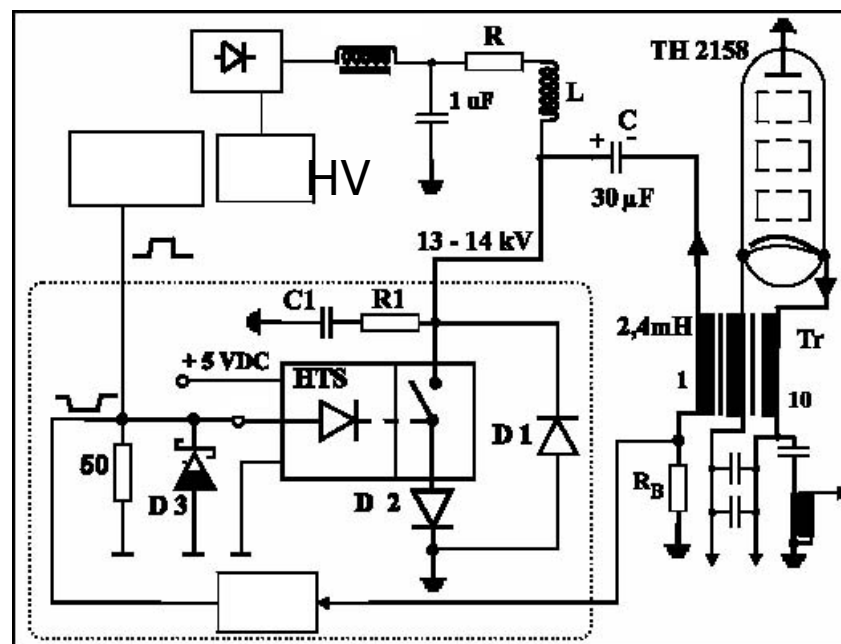


# Electron gun power supply parameters

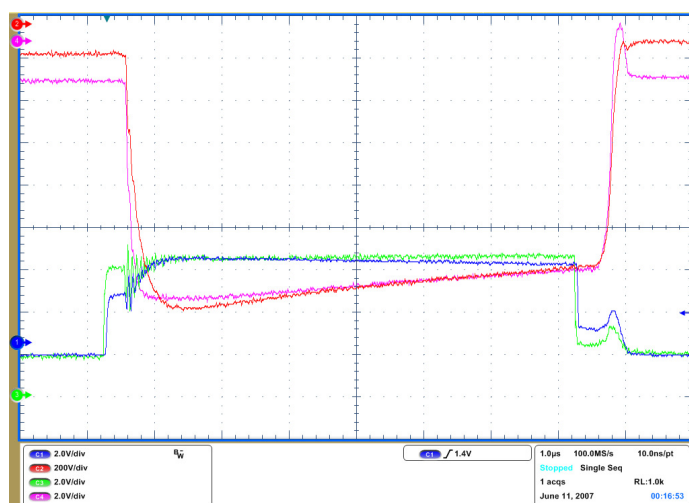
Parameter	Value
- Anode pulse amplitude	50 kV
- Grid pulse amplitude	5 kV
- Pulse current (max)	0,3 A
- Pulse duration	20 $\mu$ s
- Repetition frequency	330 Hz
- Average current	2 mA
- Pulse peak power	100 kW
- Average power	300 W
- Heater voltage	10,5 V
- Heater current	5,5 A



## TH 2158 KLYSTRON PULS MODULATOR

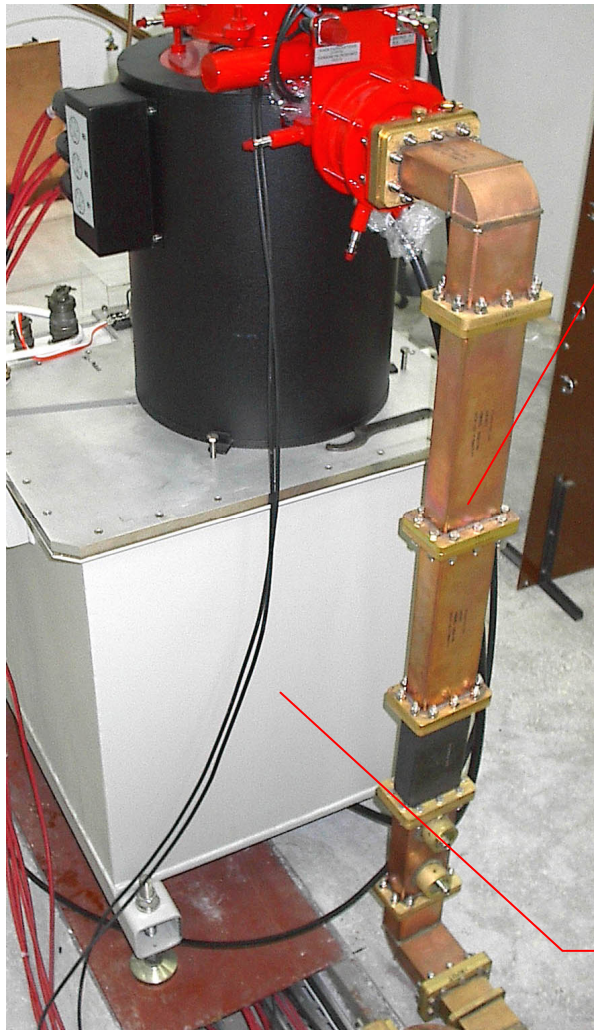


## Semiconductor switch HTS 181-160-FI



Parameters	Ratings
Voltage (max)	18 kV
Voltage in opposite direction (max)	540 V
Saturation voltage	82 (0,1 * I <sub>ampl</sub> ) V 250 (1 * I <sub>ampl</sub> ) V
Pulse current (max)	1600 A t <sub>imp</sub> < 100 μs
Pulse repetition rate (max)	500 Hz
Delay	130 ns
Rise time	80 (0,1 I <sub>ampl</sub> ) ns 180 (1 I <sub>ampl</sub> ) ns
Fall time	1 μs

# TH 2158 klystron stand



Klystron  
TH 2158

Waveguide

Focusing  
coils

Accelerating  
section

Pulse  
transformer



# MICROWAVE ENERGY SUPPLY SYSTEM



**GENERATOR**



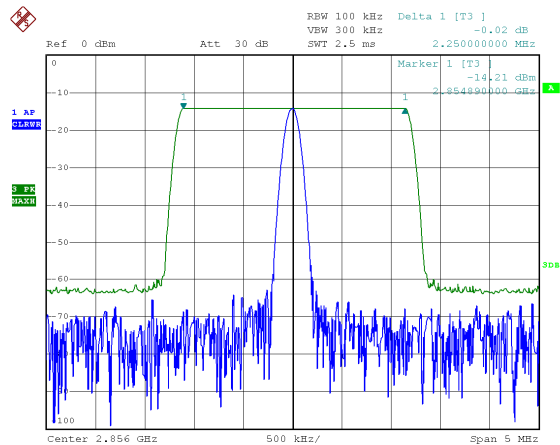
**AFC**

**C**

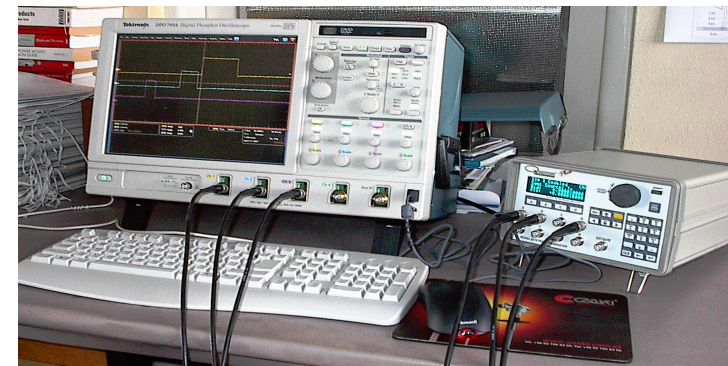
**AMPLIFIER**

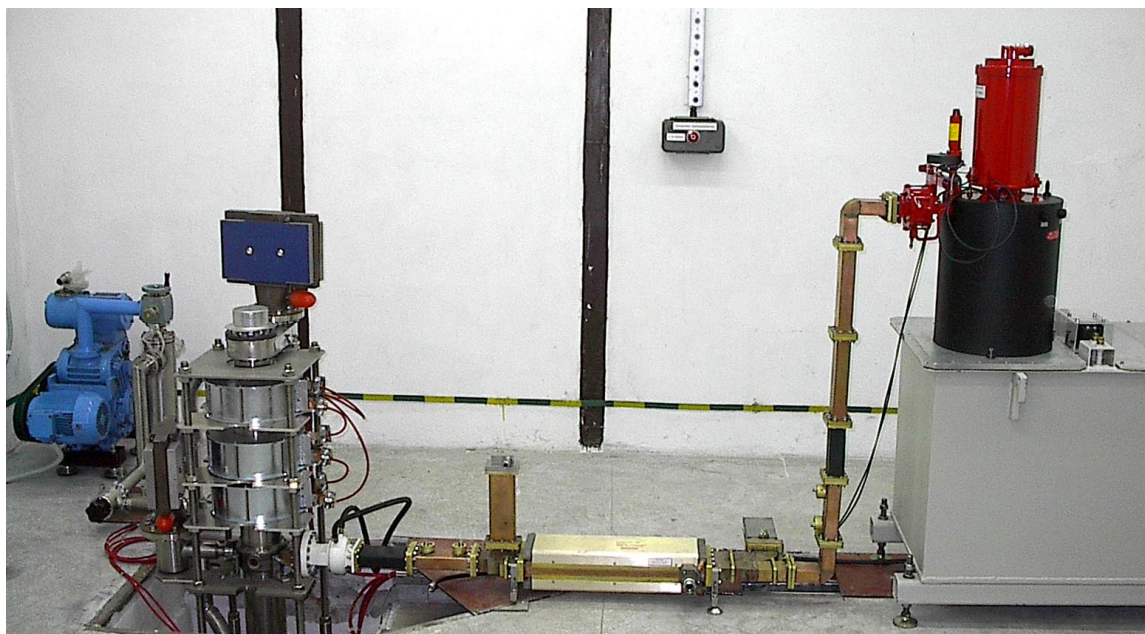


**C**



Date: 16.JUN.2008 12:43:37

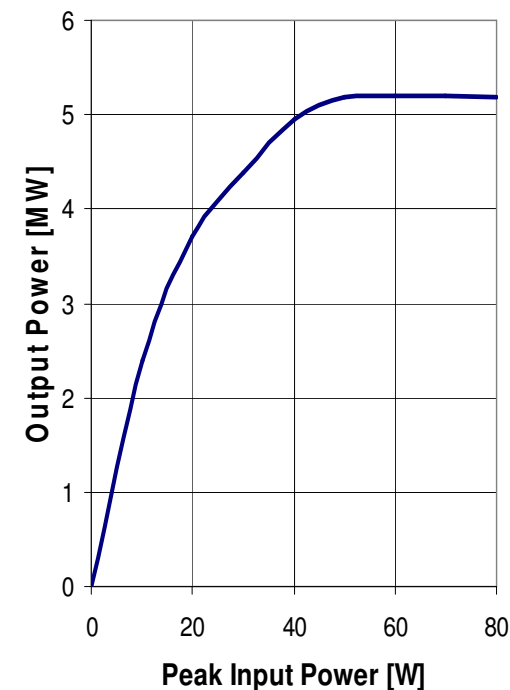
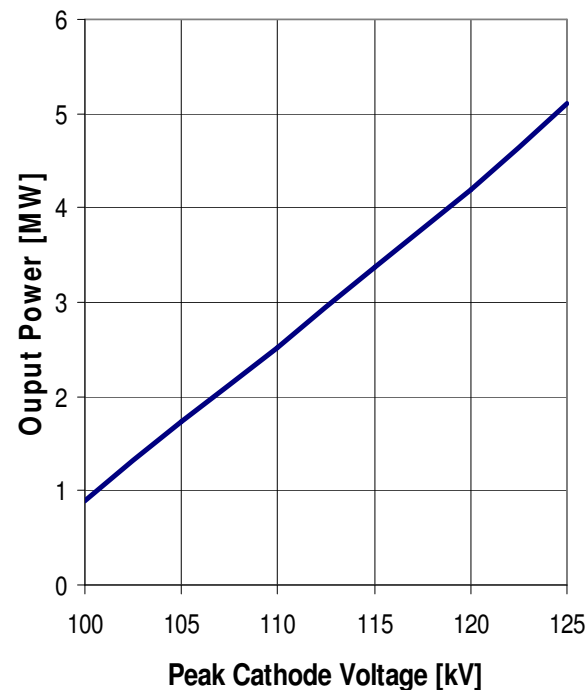


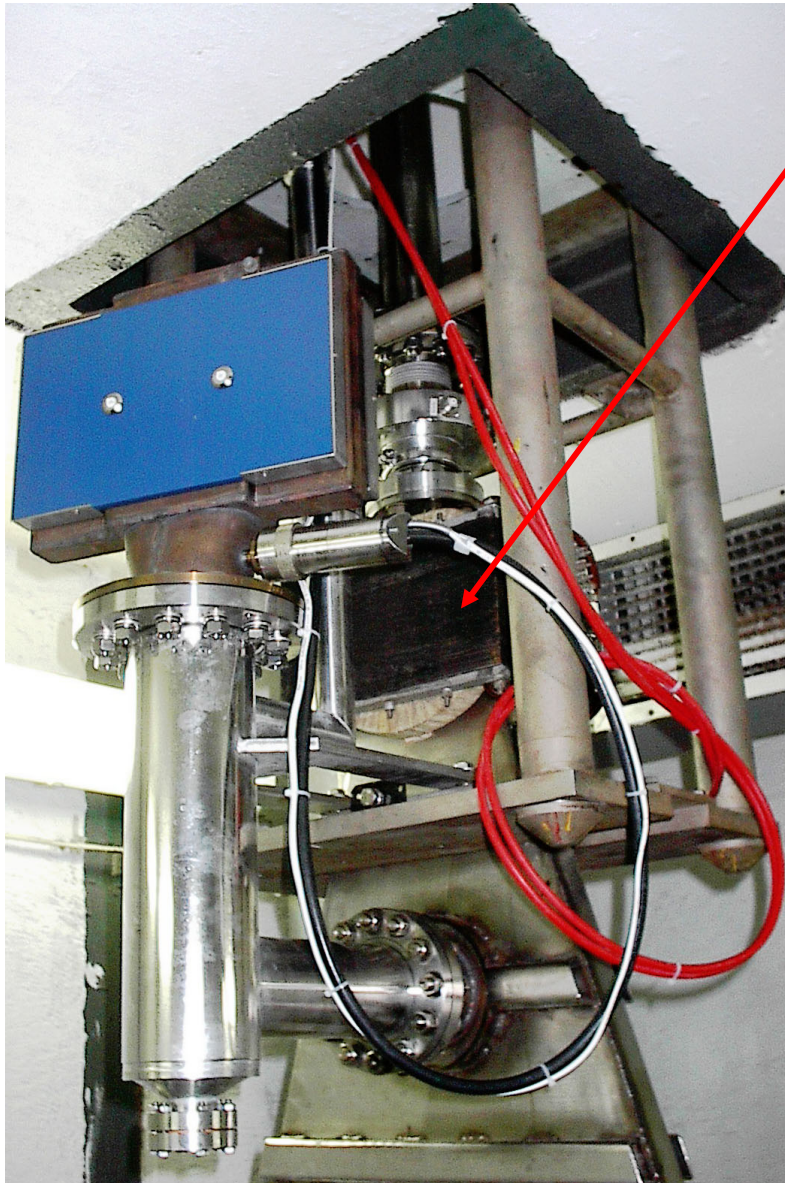


# SOURCE OF MICROWAVE ENERGY KLYSTRON TH 2158 #158011



Parameter	Measured
Pulse power (output)	5.2 MW
Average power (output)	45 kW
Pulse power (input)	64 W
Gain	49 dB
HV pulse duration	26 $\mu$ s
HV pulse amplitude	126 kV
Peak cathode current	87 A
Heater	9/31 V/A
RF Frequency	2856 MHz
RF pulse duration	27 $\mu$ s
Cooling water temperature	40 $^{\circ}$ C
pressure	8 bar
flow rate	120 l/min

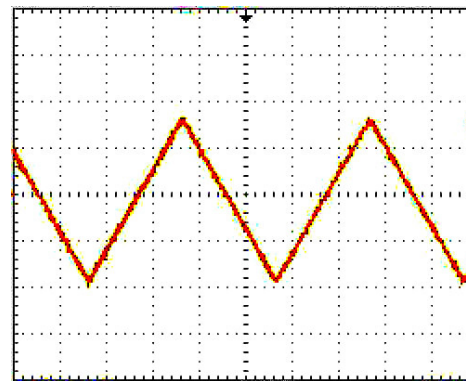




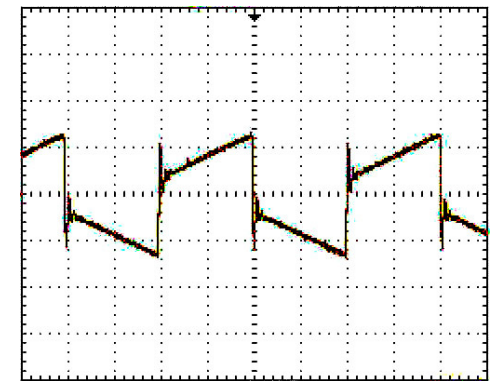
BOP 50-20MG, KEPCO Inc.

- Output power: 1 kW,
- Voltage:  $\pm 70$  V,
- Current:  $\pm 20$  A,
- Interfejs: RS232.

## Electron beam scanning arrangement

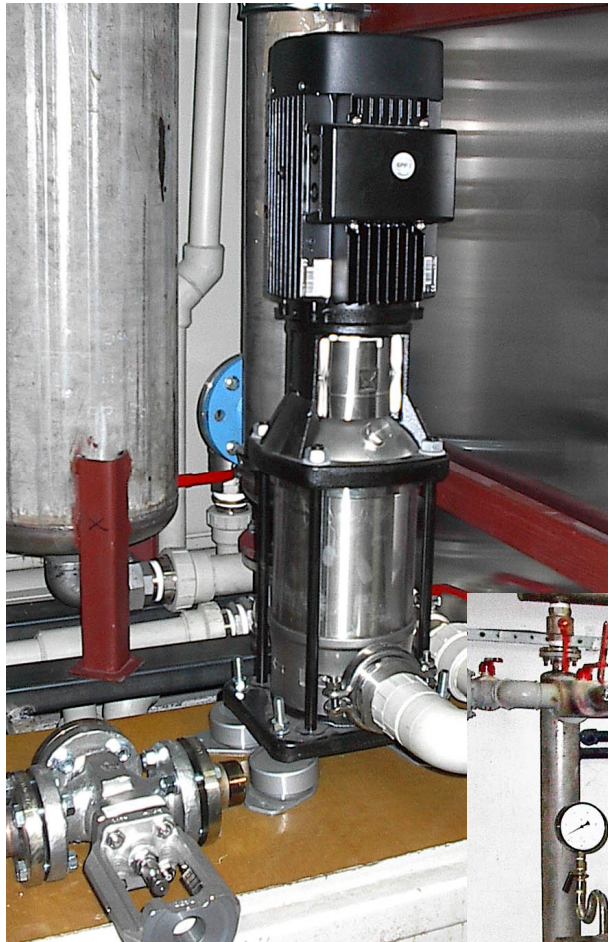


Current



Voltage

# WATER COOLING SYSTEM

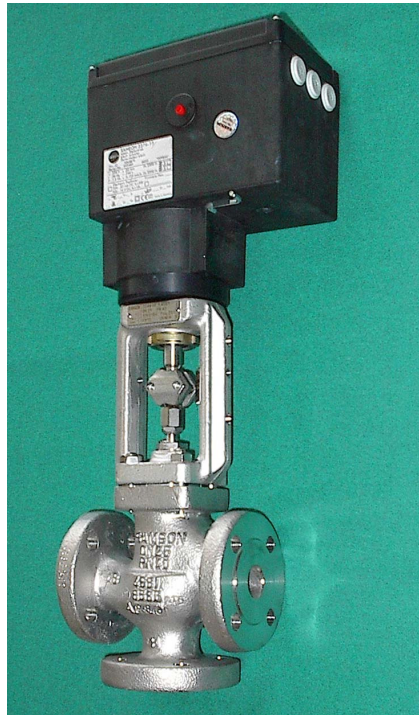


Secondary  
loop



Primary  
loop





10

11

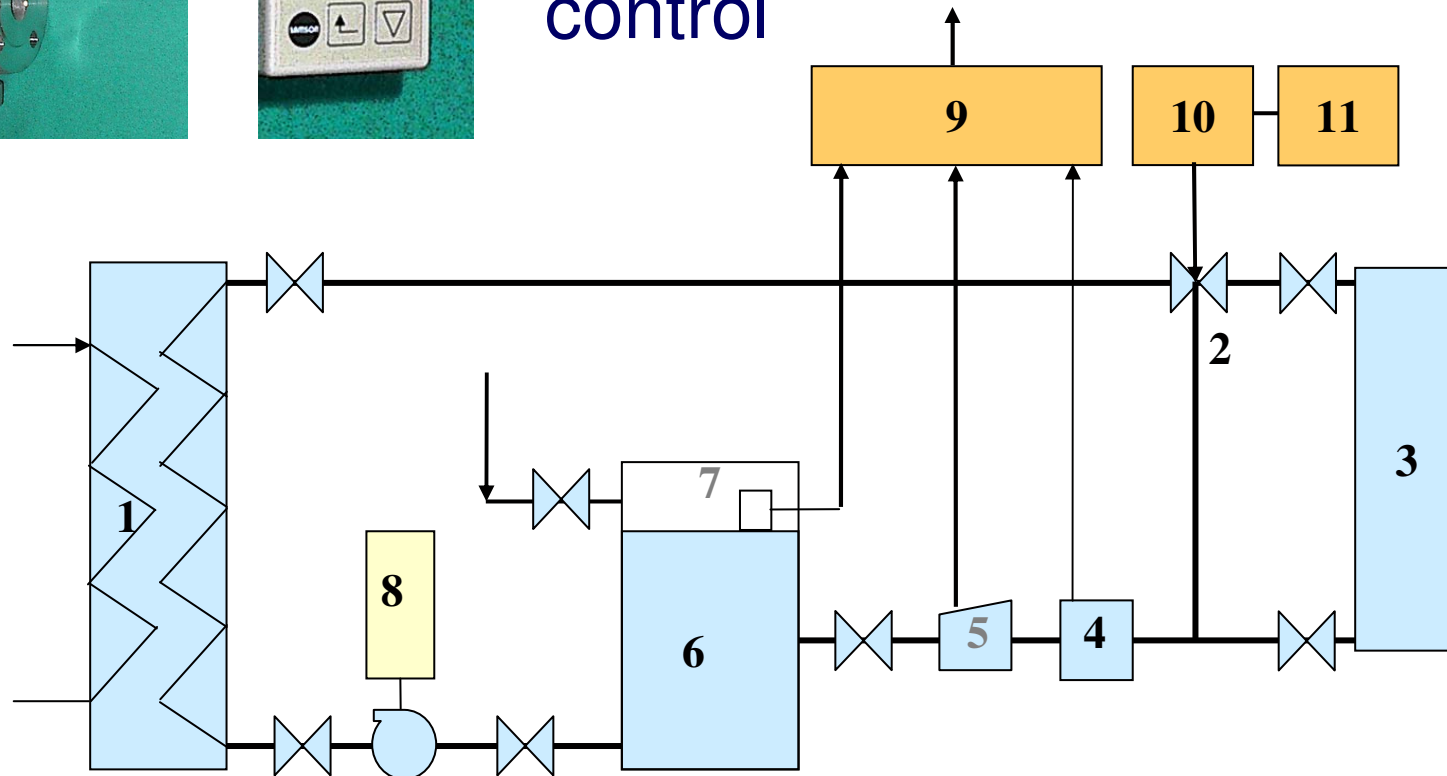


# WATER COOLING SYSTEM

Secondary loop with temperature control

- 1 – Heat exchanger;
- 2 – Valve;
- 3 – Accelerating section;
- 4 – Temperature sensor;
- 5 – Flow rate sensor;
- 6 – Water container;
- 7 – Water level sensor;
- 8 – Water pump;
- 9 – Sensors controller;
- 10 – Power unit;
- 11 – Flow rate controller.

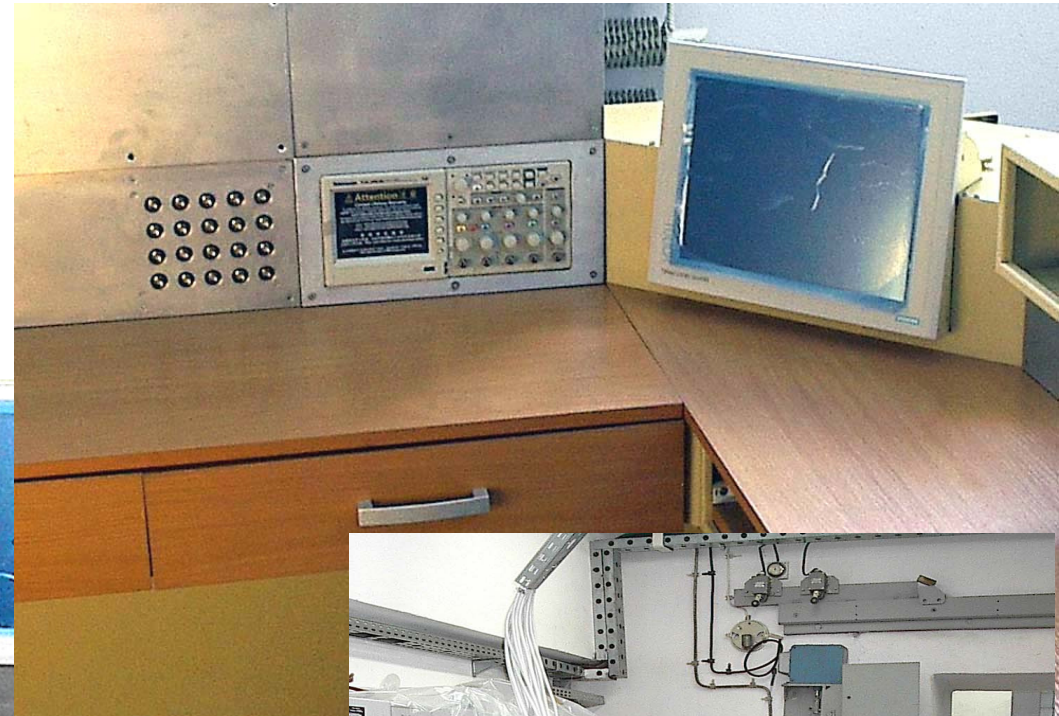
2



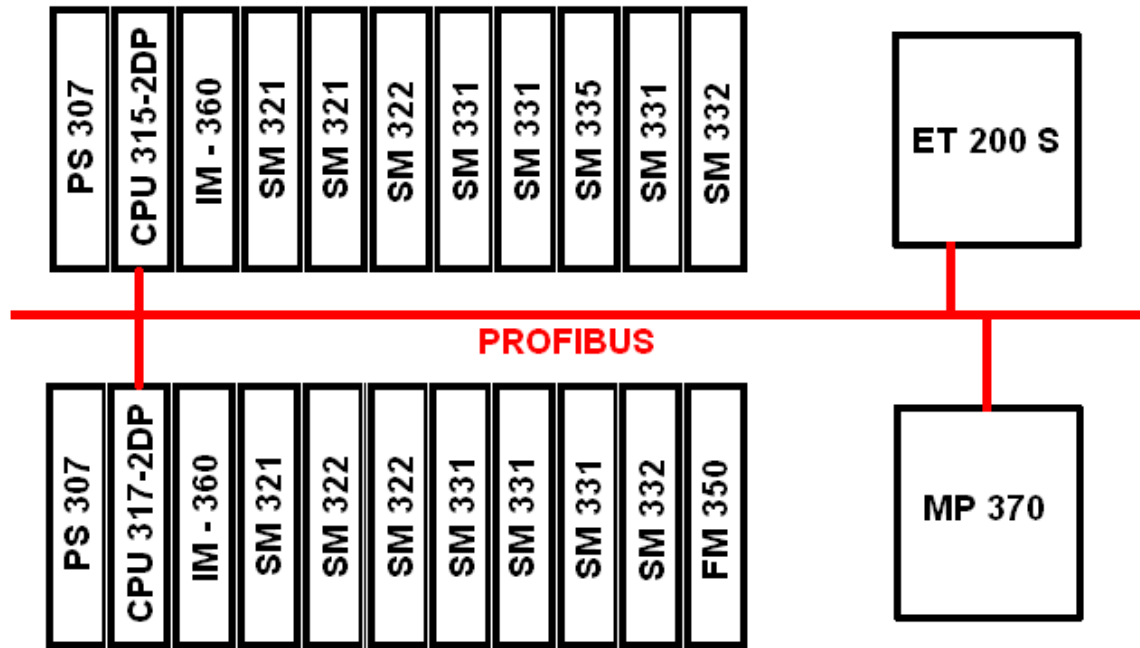
Control room

# LAE 10/15

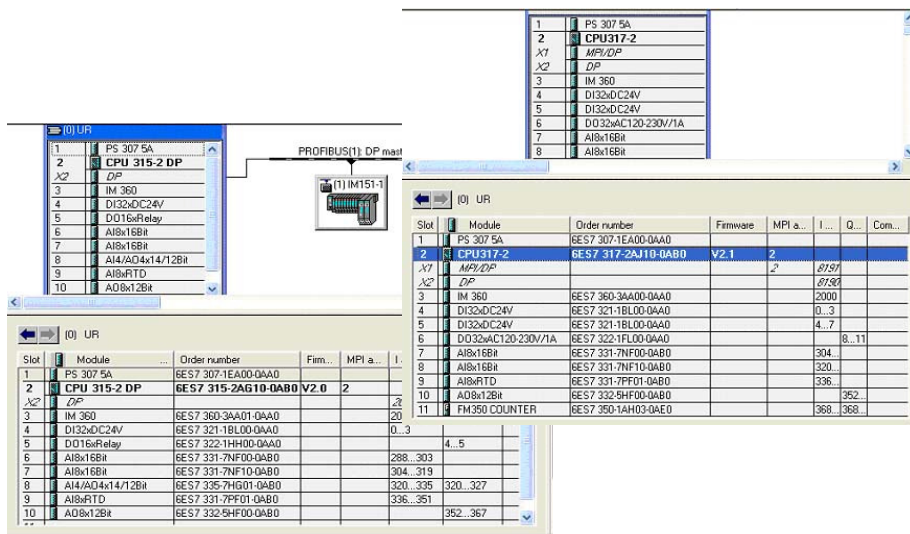
Power supplies and control panels



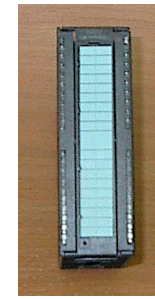
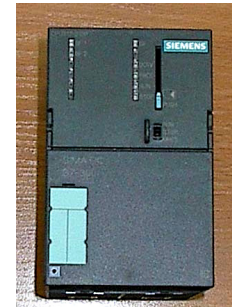
# Control system block diagram



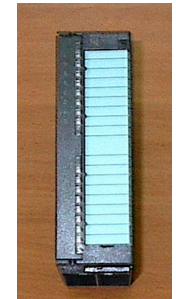
PS-307 – power supply;  
IM-360 – interface;  
SM-321 – digital input;  
SM-322 – digital output;  
SM-331 – analog input;  
SM-332 – analog input;  
SM-335 - analog output;  
FM-350 – counter;  
ET-200S – extension;  
MP-370 – touch panel.



PS-307

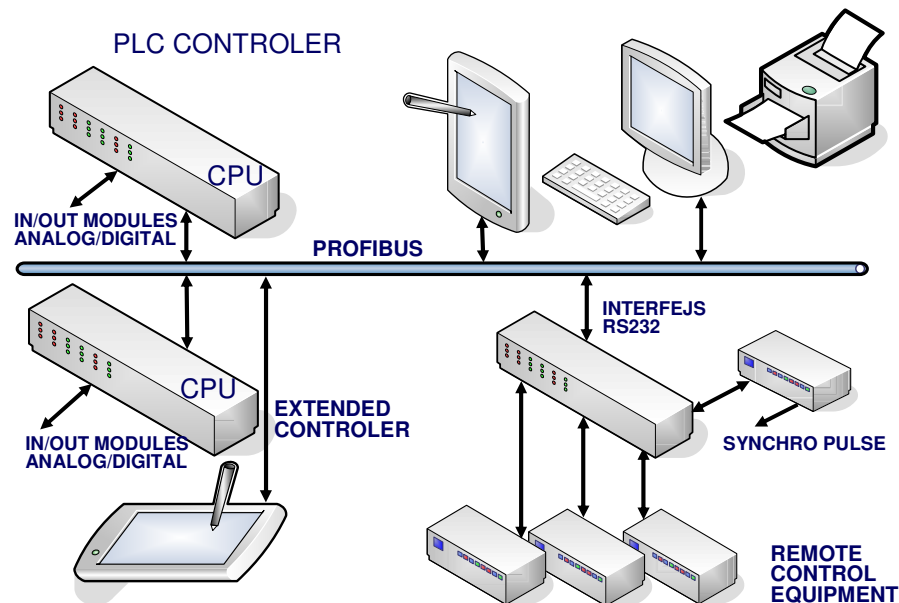


SM-321





# Control system based on Siemens modules S7-300)



# REMARKS

Electron beam alignment, beam parameters evaluation and accelerator commissioning are foreseen in the final stage of the project during last quarter of 2009.

Project realization provides opportunity to:

- international cooperation (personal, technical and financial),
- improve accelerator operational characteristics (availability, exploitation cost reduction, spare parts availability),
- introduce novel technical solutions in accelerator technology (power semiconductors technology, new generation of microprocessor control system),
- develop skills and knowledge of the personnel engaged,
- transfer the knowledge to other facilities located in Poland and central European countries.